

## PATENT ABSTRACTS OF JAPAN

(11)Publication number : 06-177109

(43)Date of publication of application : 24.06.1994

(51)Int. Cl.

H01L 21/304

(21)Application number : 04-343532

(71)Applicant : KAIJO CORP

(22)Date of filing : 01.12.1992

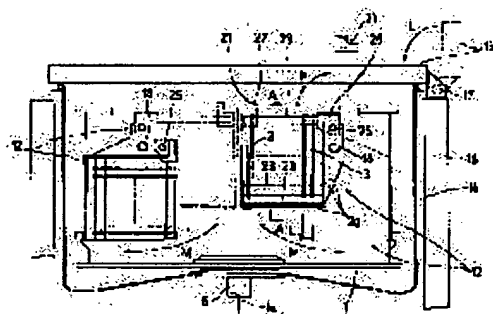
(72)Inventor : FURUKAWA HARUHIKO

## (54) CENTRIFUGAL DRYER

## (57)Abstract:

PURPOSE: To provide a centrifugal dryer which is downsized sufficiently even for a substrate having large diameter while shortening the drying time.

CONSTITUTION: A substrate holding means 12 for holding a cleaned substrate 3 directly is disposed rotatably on a turn table 1 while being set such that the main surface of the substrate 3 is normal to the center of rotation 1a of the turn table 1 at the time of centrifugal drying operation.



## LEGAL STATUS

[Date of request for examination] 24.06.1996

[Date of sending the examiner's decision of rejection]

[Kind of final disposal of application other than the examiner's decision of rejection or application converted registration]

[Date of final disposal for application]

[Patent number] 2891840

[Date of registration] 26.02.1999

[Number of appeal against examiner's decision of rejection]

BEST AVAILABLE COPY

BEST AVAILABLE COPY